



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 11, 2025

IGI Report Number

LG739582036

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

CUSHION MODIFIED BRILLIANT

Measurements

9.80 X 6.20 X 3.85 MM

GRADING RESULTS

Carat Weight

2.18 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

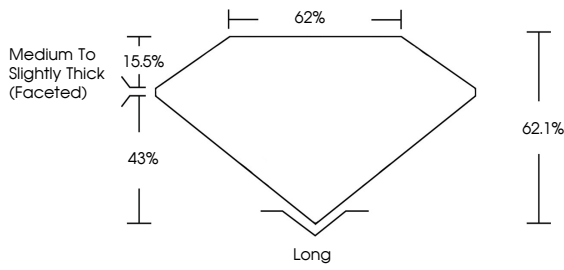
Inscription(s)

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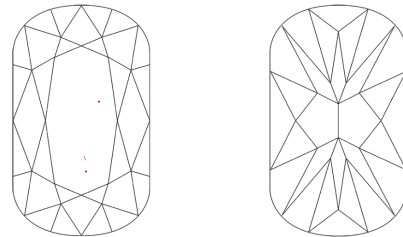
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

Report verification at [igi.org](https://www.igi.org)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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2.18 CARATS

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Depth

Table

Girdle

Medium To Slightly Thick (Faceted)

Length

Width

62.1%

62%

EXCELLENT

EXCELLENT

NONE

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Culet

Polish

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Fluorescence

Inscription(s)

None

EXCELLENT

EXCELLENT

NONE

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